

<b>Notice of References Cited</b>	Application/Control No. 10/597,970	Applicant(s)/Patent Under Reexamination VERSCHUREN ET AL.	
	Examiner Tianjie Chen	Art Unit 2627	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-4,793,480	12-1988	Gelardi et al.	206/308.1
*	C	US-5,526,342	06-1996	Akiyama et al.	720/729
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	K	US-			
	L	US-			
	M	US-			

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	N	JP 63113969 A	05-1988	Japan	MURASUGI et al.	-----
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**NON-PATENT DOCUMENTS**

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